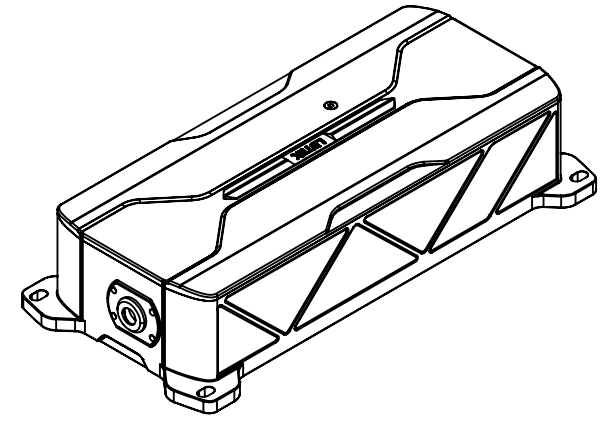
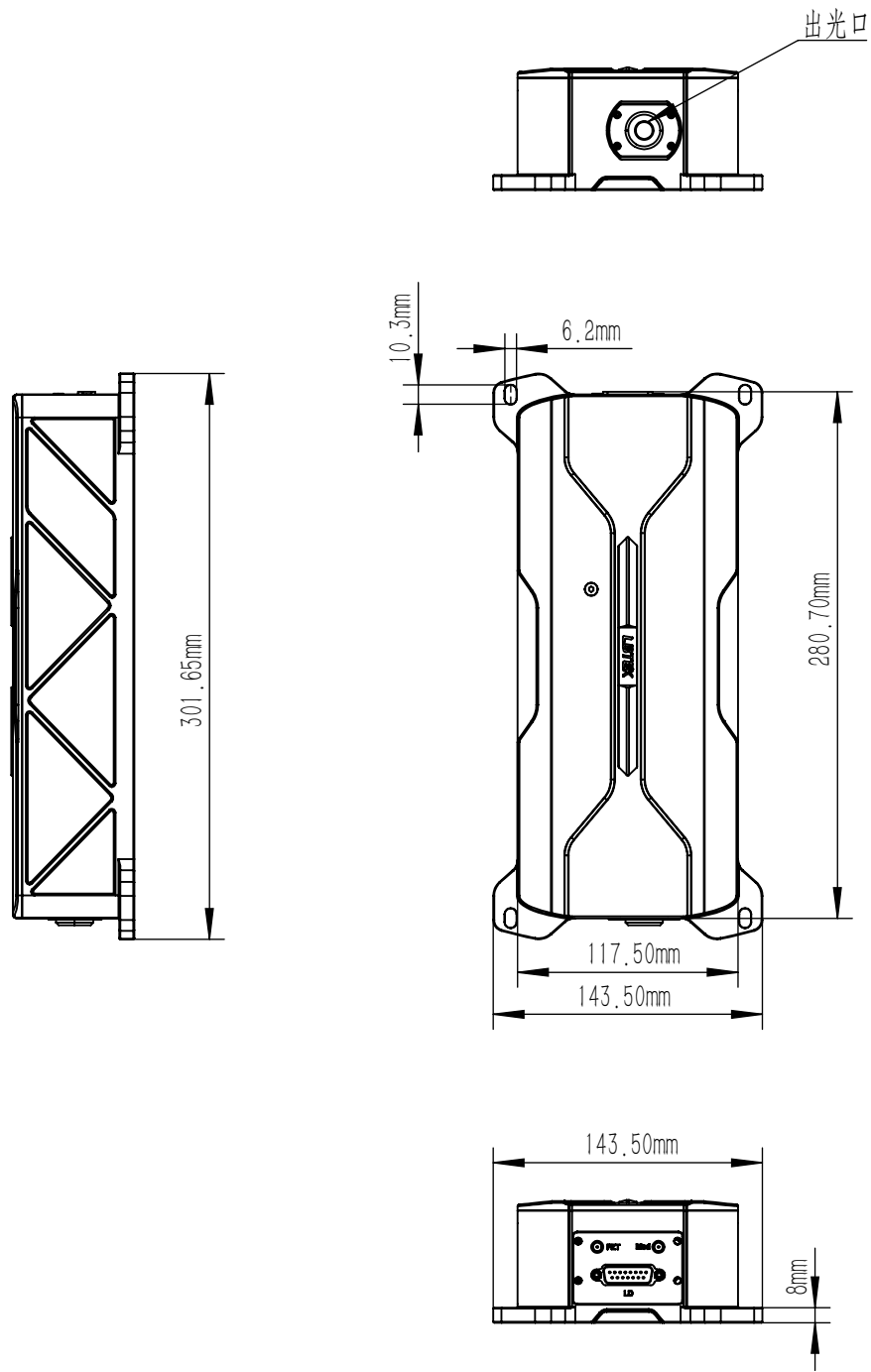




DRAWING PROJECTION			LbTEK			
	NAME	DATE	ECDL-xxx			
DRAWN	PNIU	JAN./12th/26	Narrow Linewidth Semiconductor Laser			
APPROVAL	ZHWANG	JAN./12th/26	MATERIAL	WEIGHT	SCALE	REV
FOR INFORMATION ONLY NOT FOR MANUFACTURING PURPOSES				g	1:4	A